



**ELECTRONIC COPY**

**LABORATORY GROWN DIAMOND REPORT**

June 1, 2024  
IGI Report Number **LG637443365**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **8.02 X 7.87 X 5.65 MM**

**GRADING RESULTS**

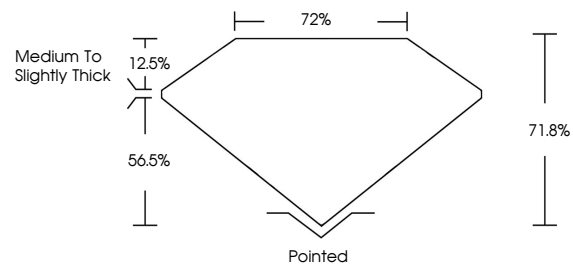
Carat Weight **3.10 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

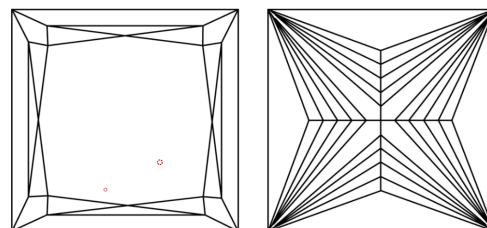
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG637443365**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**

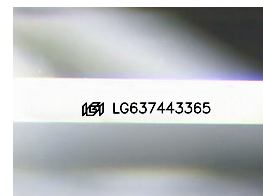


**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

**COLOR**

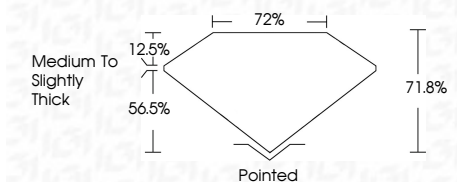
D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**

June 1, 2024  
IGI Report No. **LG637443365**  
**PRINCESS CUT**  
**8.02 X 7.87 X 5.65 MM**  
Carat Weight **3.10 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Depth **71.8%**  
Table **72%**  
Girdle **Medium to Slightly Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG637443365**  
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